

**INFORMATION DISCLOSURE STATEMENT**

Applicant : Basol et al.  
App. No : 10/782,697  
Filed : February 18, 2004  
For : METHOD OF WAFER PROCESSING  
WITH EDGE SEED LAYER  
REMOVAL  
Examiner : Michael Manh Trinh  
Art Unit : 2822  
Conf. No. : 5582

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9/26/07

(Date)



Adam Gilbert, Reg. No. 59,967

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 10 references to be considered by the Examiner. Also enclosed is 1 non-patent literature document as listed on the Information Disclosure Statement.

The Applicants herein disclose an Office Action and Notice of Allowance from co-owned U.S. Patent No. 6,833,063, which the Examiner may find relevant to Examination of the present application. The Applicants encourage the Examiner to review the entire prosecution history of this patent.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing of a Notice of Allowance. This Statement is accompanied by the fees set forth in 37 C.F.R. § 1.17(p). The Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

**Appl. No.** : 10/782,697  
**Filed** : February 18, 2004

**Docket No.** NVLUS.031CP1 (5315)  
**Customer No.** 20,995

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 9/26/07

By: Adam Gilbert

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